

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Nicholas R. Bachur, Jr. Art Unit: 1797  
Serial No.: 09/892,061 Examiner: Beisner, William H.  
Conf No: 1747  
Filing Date: 6/26/2001 Docket No: P-5026  
For: **SYSTEM AND METHOD FOR OPTICALLY MONITORING THE  
CONCENTRATION OF A GAS, OR THE PRESSURE, IN A SAMPLE  
VIAL TO DETECT SAMPLE GROWTH**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**COMMENTS ON STATEMENT OF REASONS FOR ALLOWANCE**

Sir:

Applicant hereby acknowledges the Examiner's Amendment and Reasons for Allowance. Applicant consents to the Examiner's Amendment of the claims. Applicant respectfully notes that there may be additional reasons for allowance that have not been specifically cited, and which may apply to a variety of the allowed claims, in addition to or instead of the cited Reasons. Applicant respectfully suggests that notwithstanding the Examiner's Reasons for Allowance, it is believed that each of the allowed claims is patentable in its own right and/or for other reasons raised during the prosecution and/or explained in the specification of this application.

Respectfully submitted,

/Scott J. Rittman/

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